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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
SVADIM YEVGENYEVICH BANINE ET
AL.

Confirmation Number: 2894

Application No.: 10/747,613

Group Art Unit: 2851

Filed: December 30, 2003

Examiner: Della J. Rutledge

For: LITHOGRAPHIC APPARATUS AND RADIATION SOURCE COMPRISING A
DEBRIS-MITIGATION SYSTEM AND METHOD FOR MITIGATING DEBRIS
PARTICLES IN A LITHOGRAPHIC APPARATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT/RESPONSE TRANSMITTAL

Transmitted herewith is an amendment/response for this application.

EXTENSION OF TIME

The proceedings herein are for a patent application and the provisions of 37 C.F.R. 1.136 apply. Applicant petitions for a 1 month extension of time under 37 C.F.R. 1.136.

FEEES

The fee for claims and extension of time (37 C.F.R. 1.16 and 1.17) has been calculated as shown below:

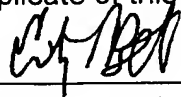
CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDIT. FEE
TOTAL	19	20	0	0.00
INDEP.	5	5	0	0.00
FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				0.00
TOTAL ADDITIONAL CLAIM FEE				0.00
EXTENSION OF TIME FEE				120.00
GRAND TOTAL				120.00

FEE PAYMENT

Authorization is hereby made to charge the amount of \$120.00 to Deposit Account No. 033975. Charge any additional fees required by this paper or credit any overpayment in the manner authorized above. A duplicate of this paper is attached.

Date: June 16, 2006

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